


PATENT
700623-3003

In The United States Patent and Trademark Office

<p>In re Application of:</p> <p>Assignee: Technologies and Devices International, Inc.</p> <p>Inventors: Yuri V. Melnik, <i>et al.</i></p> <p>App. No: 10/632,736</p> <p>Filed: August 1, 2003</p> <p>Title: Reactor for Extended Duration Growth of Gallium Containing Single Crystals</p> <p>Docket: 700623-3003</p>	<p>Art Unit: 1763</p> <p>Examiner: Moore, Karla A.</p> <p>CERTIFICATE OF MAILING UNDER 37 CFR § 1.8</p> <p>Date of Deposit: October 4, 2005</p> <p>I hereby certify that this document is being deposited with the United States Postal Service first class mail on the date indicated above in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.</p> <p>Type or Print Name of Person Mailing: Karen Wuerfel</p> <p> Signature of Person Mailing</p>
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AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Commissioner:

In response to non-final Office action mailed May 20, 2005, please amend the above-identified application as follows:

10/11/2005 AKELECH1 00000007 502518 10632736
02 FC:2202 150.00 DA